

Notice of References Cited		Application/Control No. 10/589,986	Applicant(s)/Patent Under Reexamination ARPAC ET AL.	
		Examiner Vivian Chen	Art Unit 1787	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,703,131	03-2004	Kayanoki, Hisayuki	428/446
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	M	US-			

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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